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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/774,362
Filing Date: February 6, 2004
Applicant: Yoshihide Matsuo
Group Art Unit: 2815
Examiner: WARREN, Matthew E
Title: MANUFACTURING METHOD FOR SEMICONDUCTOR DEVICE,
SEMICONDUCTOR DEVICE,
AND ELECTRONIC APPARATUS
Attorney Docket: 9319G-000679

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

SECOND PRELIMINARY AMENDMENT

Sir:

Prior to examination of the present application, please consider the following.

Amendments to the Specification begin on page 2 of this paper.

Remarks begin on page 4 of this paper.